

The European Synchrotron

Probing the Time-Resolving Capabilities of XIDer Assemblies with CdTe and CZT sensors

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Through the upgrade to a 4^{th} -generation storage ring, the **Extremely Brilliant Source** (EBS), the X-ray beam at the European Synchrotron (ESRF) is x100 more brilliant, has a x40 coherent fraction, and can reach photon energies of ≤ 100 keV.

The **XIDer** R&D project between the ESRF and Heidelberg University is developing 2D pixelated detectors for **time-resolved scattering and diffraction experiments** for EBS beam-lines focusing on, for example, material properties under dynamic pressure, monitoring chemical processes in 4D, and protein folding. These new research opportunities opened by the EBS require state-of-the-art detectors.

1. XIDer architecture

• Novel on-chip **incremental digital integration** readout is implemented with per-pixel digital data output per subframe.

4. Time-synchronous orbit scan measurements

X-ray measurements performed at BM05, ESRF with XIDer subframes **time-synchronous to the bunch arrival**. By changing the **delay** between the bunch arrival signal and the subframe start, different portions of photon-induced signal from the sensor can be probed.

 Two-stage pipelined ADC: In each stage, while amplified signal > threshold, a packet of charge is removed



2. Prototypes



• Sensor: CdTe-Ohmic (Acrorad) or CZT (Due2Lab & Redlen)



Data taking: 30keV 4-bunch X-ray beam incident on XIDer assembly, attenuated to different fluxes using planar AI filters.



Example of 4-bunch full orbit scan using CdTe-O assembly

- Pixels: 4x4 matrices of 100 or 200µm pitch
- ASIC: TSMC CMOS 65nm technology (version T4)
- Interconnection: by Polymer Assembly Technology
- Readout: PETA system from
 Heidelberg University

3. Proof-of-principle single-bunch isolation

X-ray measurements performed at BM05, ESRF as **proof-ofprinciple** bunch isolation measurements using CdTe-O sensors: **front-end buffer output** analysis using an oscilloscope.

36µs (σ =7.2ns) av. rise-time, negligibly effected by the use of a buffered output.



Flux of 76.1 30keV Mph mm⁻² s⁻¹.

Mean inter-bunch time: **707**ns +/- **4**ns.

CZT and CdTe-O inter-bunch comparison

Fluxes for datasets: [30keV Gph mm⁻² s⁻¹]



Significantly higher

A 30keV 4-bunch X-ray beam, attenuated to 1-4ph pix⁻¹ subframe⁻¹

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signal recorded between bunches for CdTe sensor compared to CZT.

5. Conclusion

- Time-resolving capabilities of XIDer tested with readout-beam synchronisation using 4-bunch EBS beam of 30keV photons
- Assemblies with CZT and CdTe-O sensors compared using XIDer-bunch orbit scan, showing higher inter-bunch signal for an assembly with a CdTe sensor compared to CZT.